

AF\$
mw

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re the Application of:

Moon-Chul LEE, et al.

Art Unit: 1765

Serial No. 10/681,217

Examiner: Kin Chan Chen

Filed: October 9, 2003

Confirmation No. 8341

For: METHOD OF FORMING A VIA HOLE THROUGH
A GLASS WAFER

Attorney Docket No. 277/018

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop Amendments After Final
Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action Made Final, mailed October 31, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

Amendments to the Claims are reflected in a listing of the claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.